



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Yuichiro MATSUO et al.

Serial No.: 10/715,403

PTO Confirmation No.: 1169

Filed: November 19, 2003

For: NEGATIVE ION GENERATING MEDIUM AND ITS MANUFACTURING
METHOD

Attorney Docket No.: 032114

Customer Number: 38834

RESPONSE TO NOTICE TO FILE CORRECTED APPLICATION PAPERS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 9, 2004

Sir:

In response to the Notice to File Corrected Application Papers dated May 24, 2004, please
amend the above-identified patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 3 of this paper.